
DRD1 Collaboration Meeting

Capacitive-Sharing Pixel Micromegas Detector

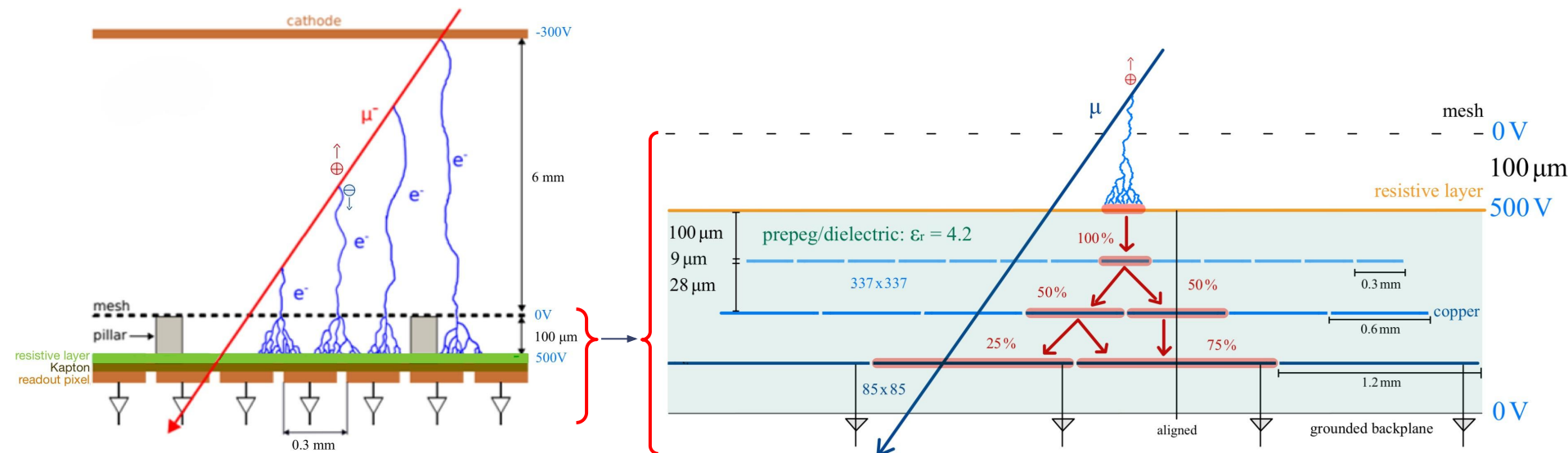


MAX MENZER
LMU: AG BIEBEL
8 October, 2025

Signal Readout - Capacitive-Sharing

Goal: Reduce the number of readout channels

- Multiple layers of pixels that double in size
→ no electrical contact (dielectric)
- Readout only on the biggest pixels (readout pixels)

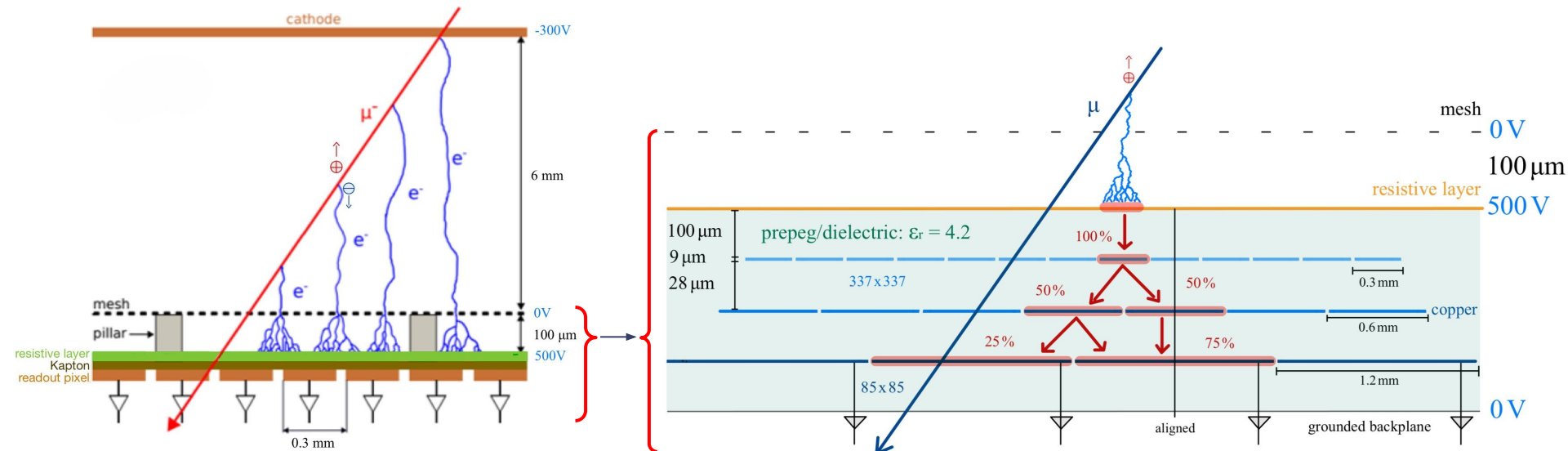


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3 layers: reduce readout
pixels by factor $\sim 1/16$:
10 cm x 10 cm detector
113 500 $\rightarrow$ 7225



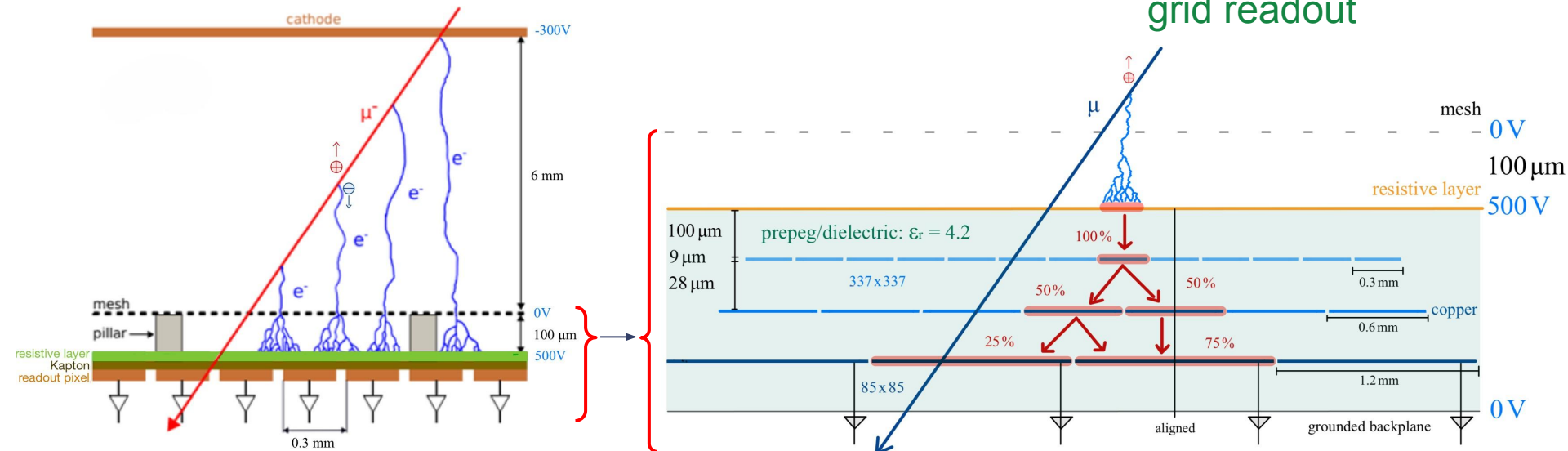
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10 cm x 10 cm detector
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Actual detector
requires only 170
channels through a
grid readout

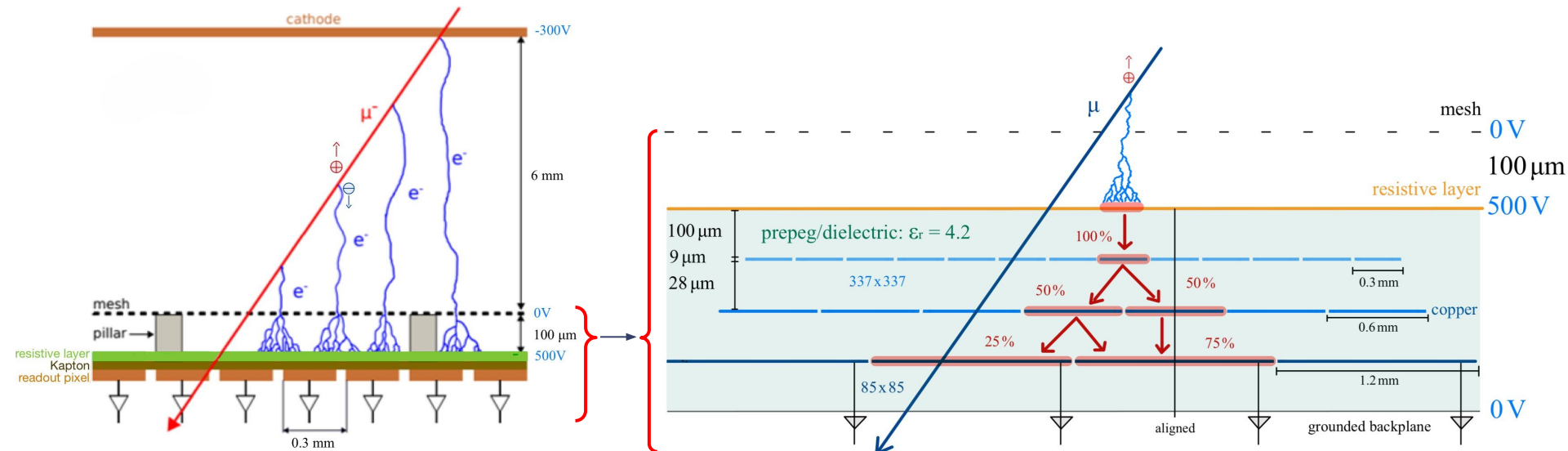


Signal Readout - Capacitive-Sharing

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- Readout only on the biggest pixels (readout pixels)
- Capacitive-Sharing allows the signal to travel downwards and split
- Unique readout for each position

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Signal Readout - Capacitive-Sharing

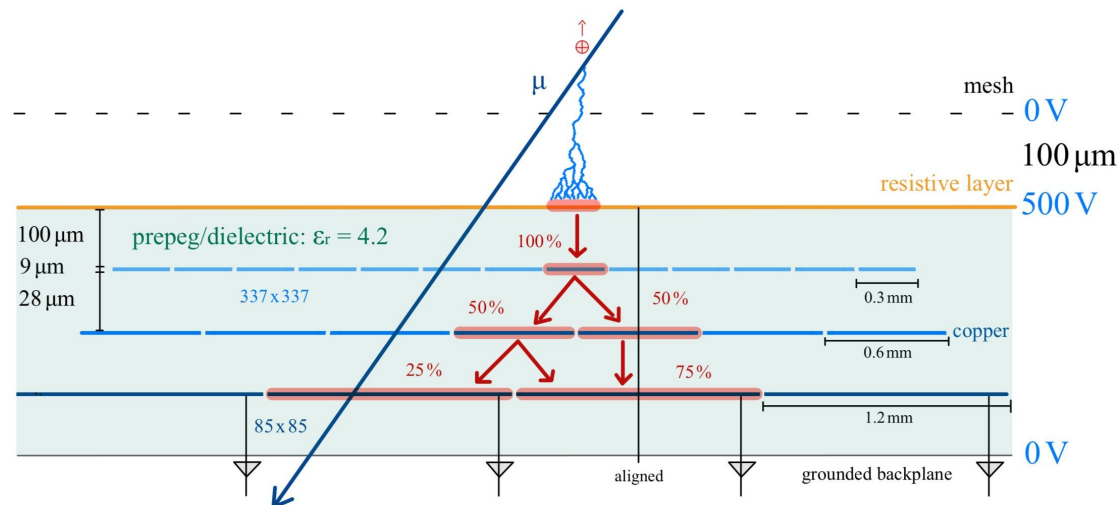
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3 layers: reduce readout
pixels by factor ~ 1/16:
10 cm x 10 cm detector
113500 → 7225

weighted arithmetic mean
→ resolution in the order
of the smallest pixels

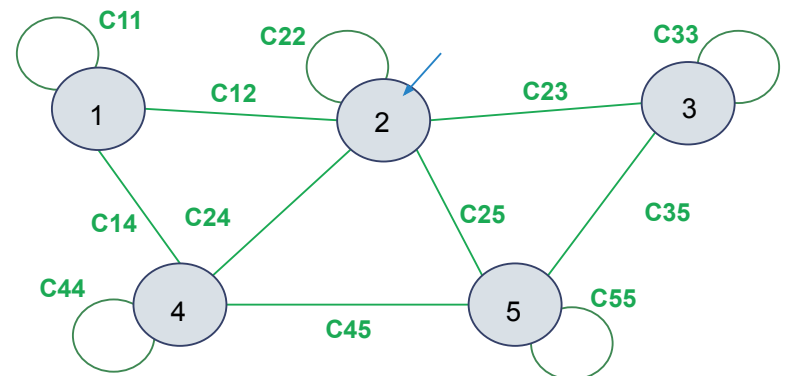
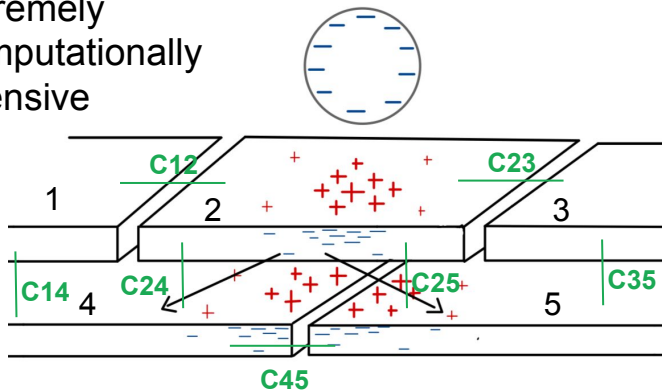
$$x_{rec} = \frac{\sum_{i=1}^n w_i x_i}{\sum_{i=1}^n w_i}$$



Two Theories for Capacitive-Sharing

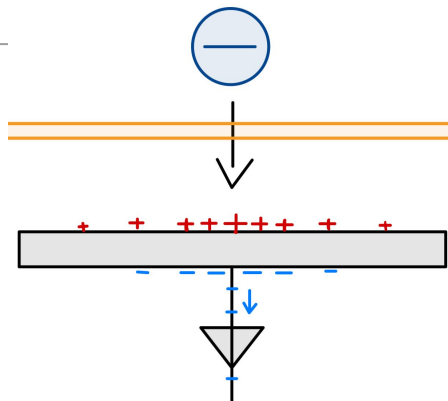
Equivalent Circuit	Ramo-Shockley Theorem
- capacitances can be calculated between each pair of pixels - an equivalent circuit can replicate the detector - a signal can be injected (pixel 2) and its propagation observed	

extremely
computationally
intensive



Two Theories for Capacitive-Sharing

Equivalent Circuit	Ramo-Shockley Theorem
- capacitances can be calculated between each pair of pixels - an equivalent circuit can replicate the detector - a signal can be injected (pixel 2) and its propagation observed	- a moving charge pushes charge carriers into the readout <u>weighting field</u> is a mathematical concept and a non real electric field - ground all electrodes except electrode j, the one under consideration (1V)



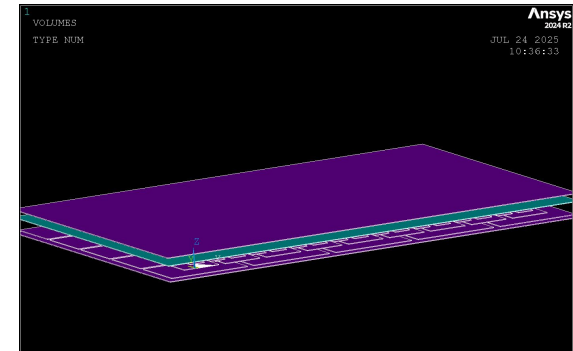
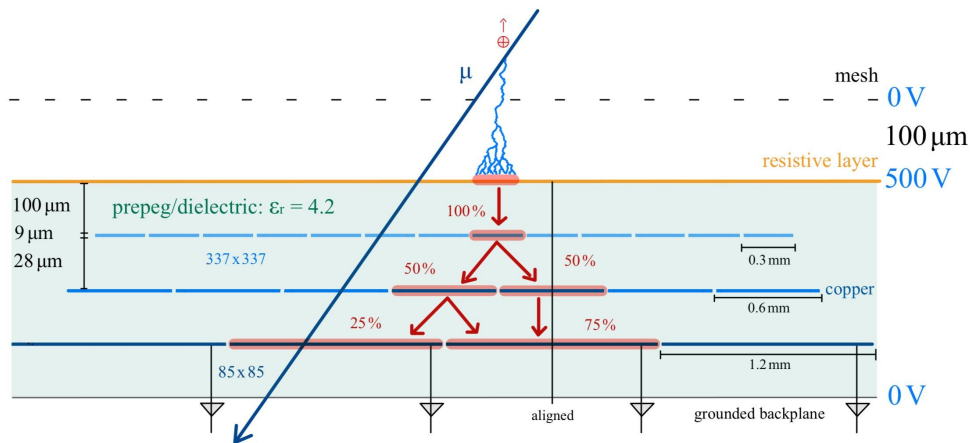
$$i_j(t) = -q\mathbf{v}(t)\mathbf{E}(\mathbf{x}(t))w_{,j}$$

Ramo Shockley Theorem

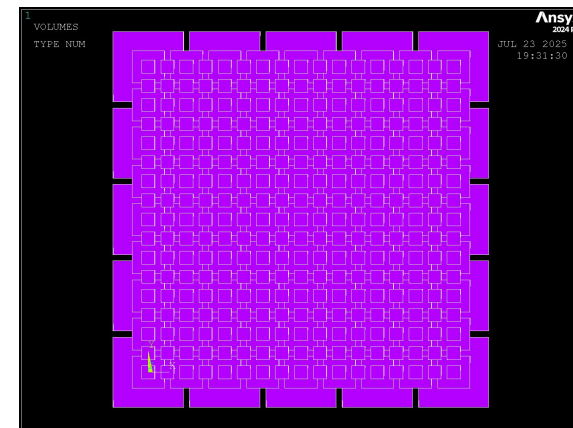
(Notes Djunes Janssens [1])

Setup for the ANSYS Simulation

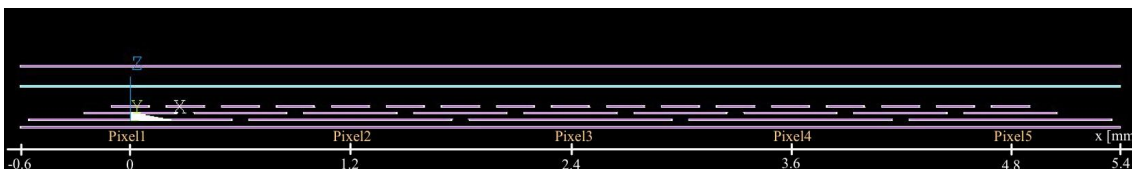
Focus on a section of 5x5 readout pixels



detector structure with mesh,
dlc, pixels and backplane



top view pixels only



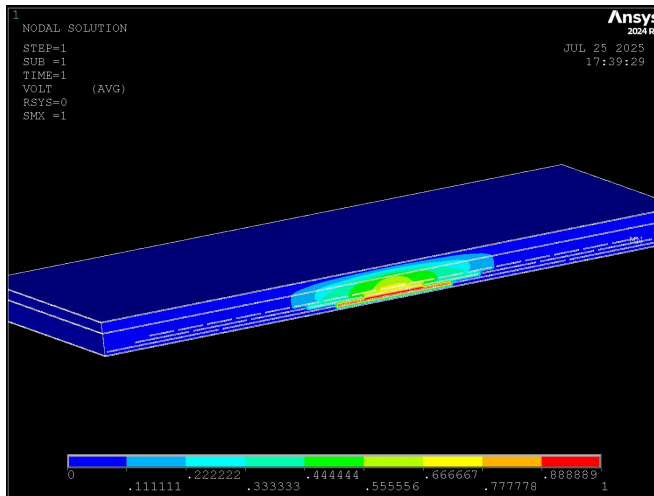
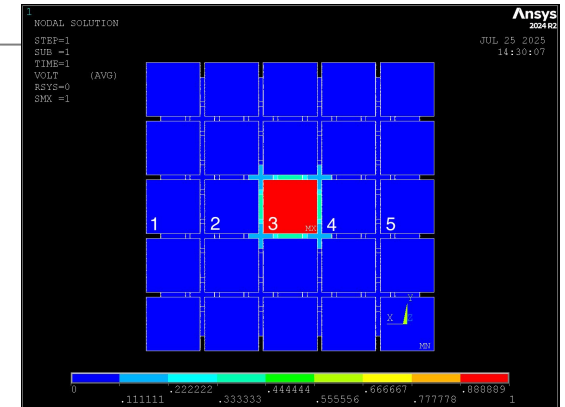
cross section with copper parts purple and dlc cyan

$$i_j(t) = -q\mathbf{v}(t)\mathbf{E}(\mathbf{x}(t))_{w,j}$$

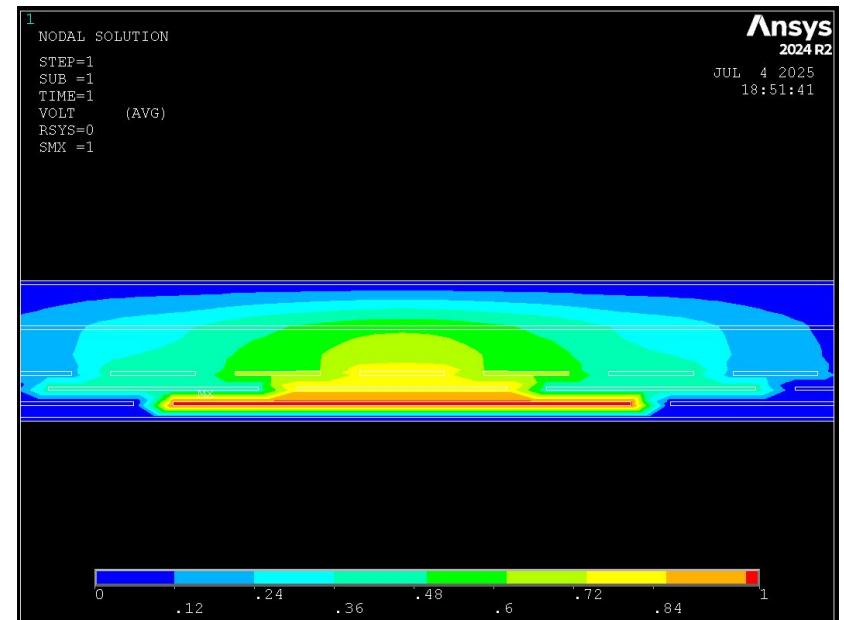
Weighting field for j=3

Electric potential with boundary conditions:

- Electrode/readout pixel j is set to unit potential (1V - red)
- All other electrodes are grounded
- The other pixel layers are floating



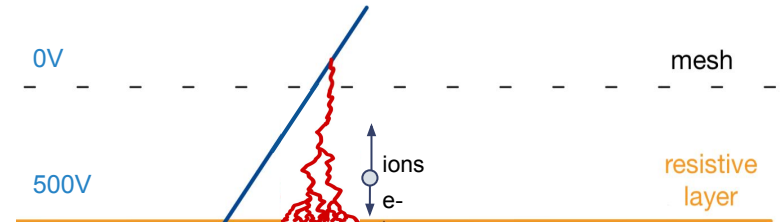
cross section along x: Readout pixels 1 to 5 visible



$$i_j(t) = -q \mathbf{v}(t) \mathbf{E}(\mathbf{x}(t))_{w,j}$$

Path integral Approach

- Electrons drift to the dlc, ions to the mesh
- Total induced charge is the integrated Ramo-Shockley current



$$Q_j = Q_{j,e} + Q_{j,i} = \int_0^{t_e} i_{j,e}(t) dt + \int_0^{t_i} i_{j,i}(t) dt$$

Electron drift gives a path integral

$$\begin{aligned} Q_{j,e} &= -q \int_0^{t_e} \mathbf{v}(t) \mathbf{E}(\mathbf{x}(t))_w dt = -q \int_0^{t_e} \frac{d\mathbf{x}(t)}{dt} \nabla \phi(\mathbf{x}(t))_w dt = -q \int_0^{t_e} \frac{d\phi(\mathbf{x}(t))_w}{dt} dt \\ &= -e (\phi(\mathbf{x}_{dlc})_w - \phi(\mathbf{x}_0)_w) \end{aligned}$$

Add ion contribution to get total charge on readout pixel/electrode j

$$Q_j = -e (\phi(\mathbf{x}_{dlc})_w - \phi(\mathbf{x}_{mesh})) \sim \phi(\mathbf{x}_{dlc})$$

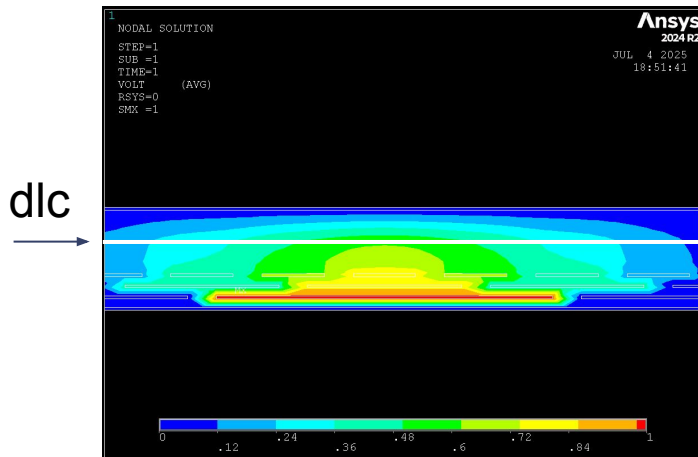
$$Q_j \sim \phi(\mathbf{x}_{dlc})$$

Path integral Approximation

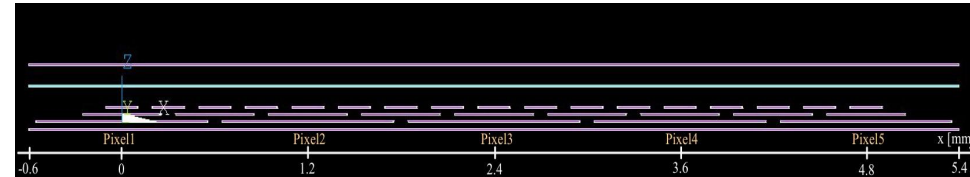
Use charge Q_i as weighting w_i for reconstruction in one dimension

$$x_{rec} = \frac{\sum_{i=1}^n w_i x_i}{\sum_{i=1}^n w_i}$$

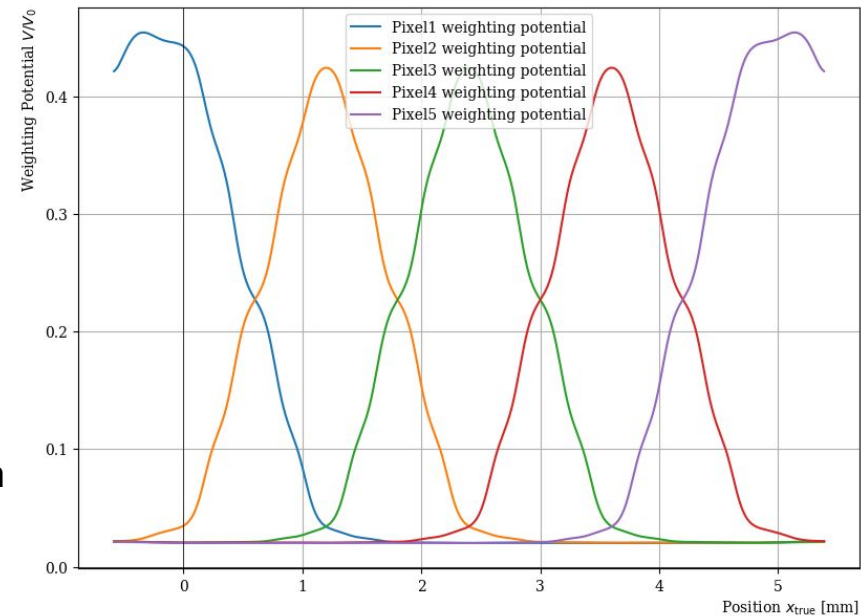
Project weighting potential at the dlc onto the y axis



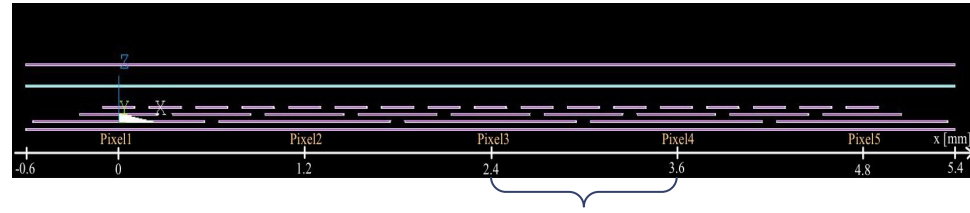
pixel3 → green



setup: cross section along x for reconstruction



Reconstruction

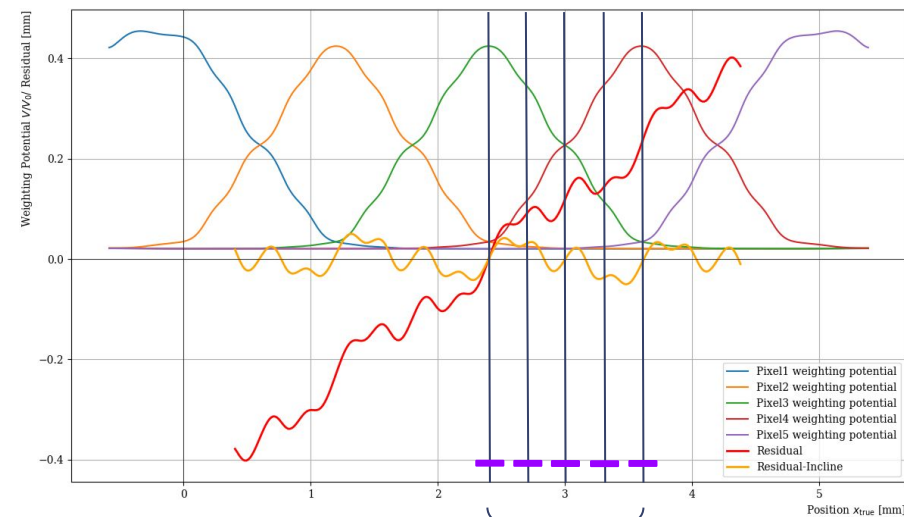
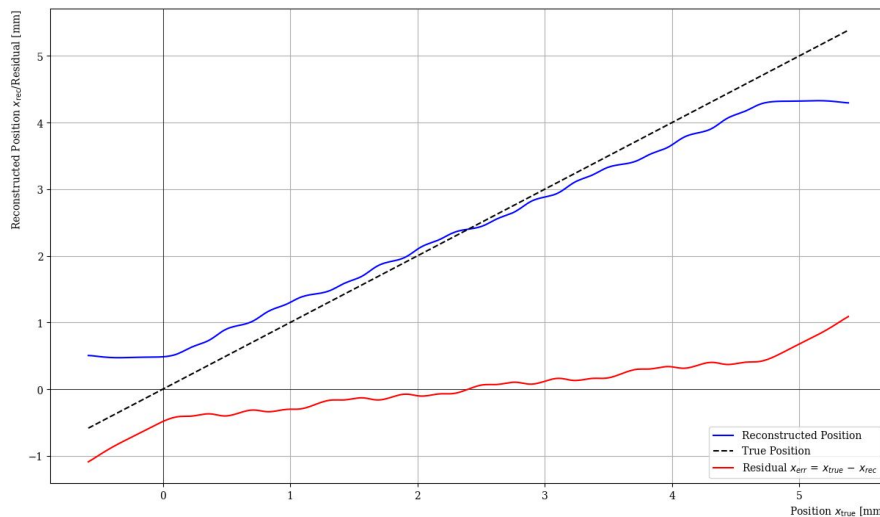


periodicity of the readout pixels or 4 smallest pixels

“Move” test charge from left to right:

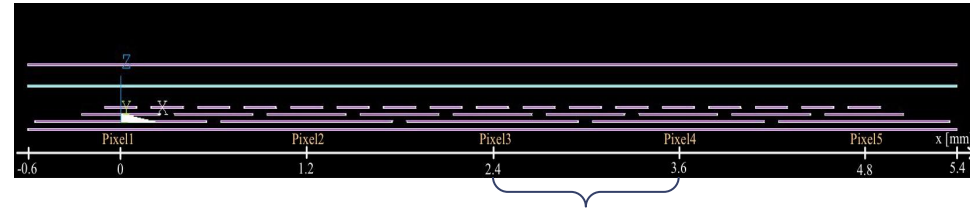
Residual shows an inclination and oscillation

- Inclination results from limited size of the model (5x5)
- Oscillation from plateaus in the weighting potential



periodicity of the readout pixels or 4 smallest pixels

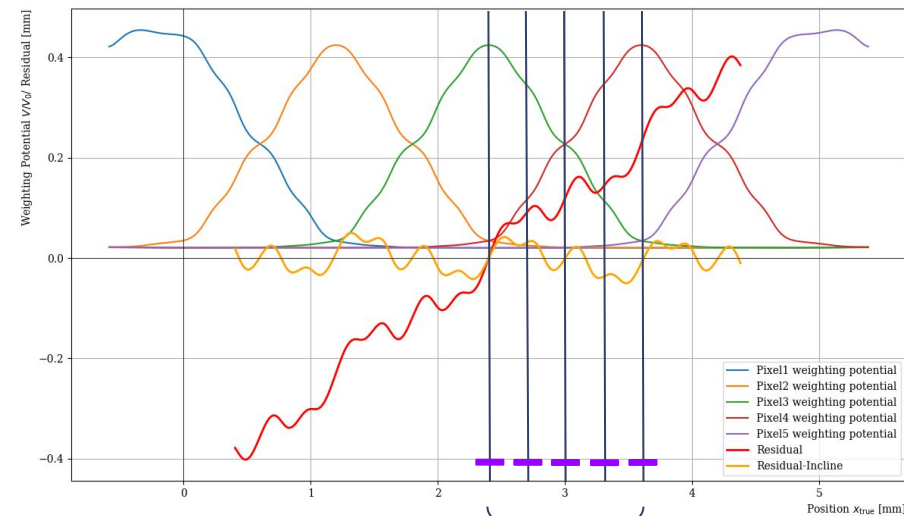
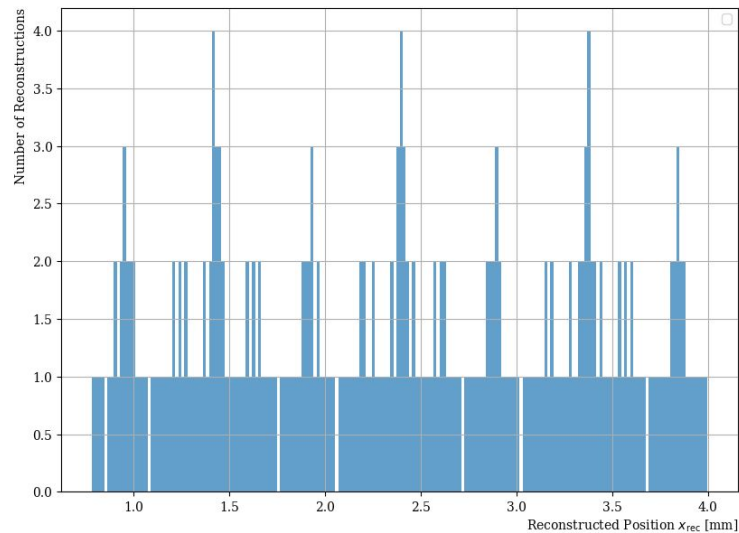
Reconstruction



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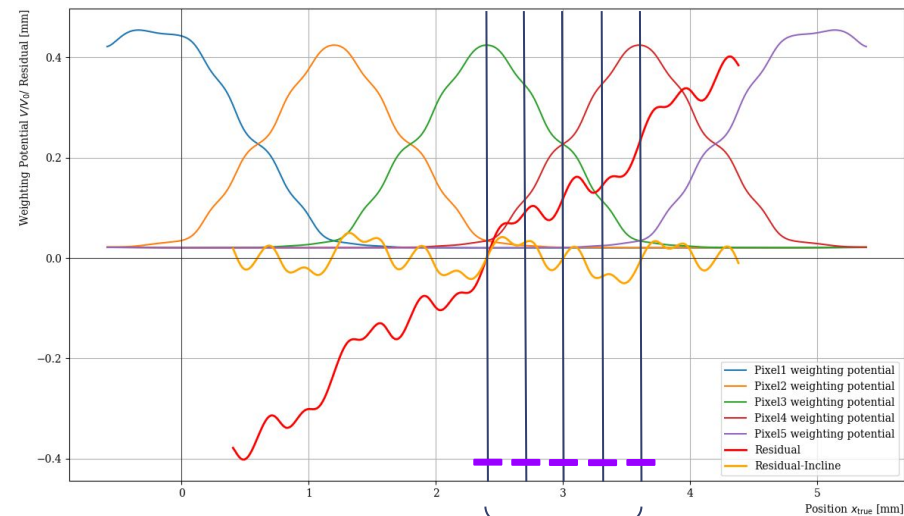
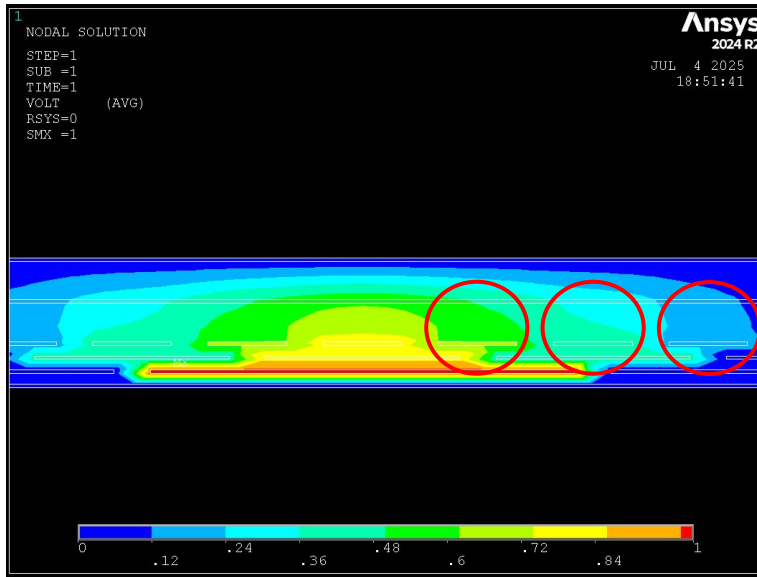
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- Oscillation from plateaus in the weighting potential



periodicity of the readout
pixels or 4 smallest pixels

Oscillations of the Residual

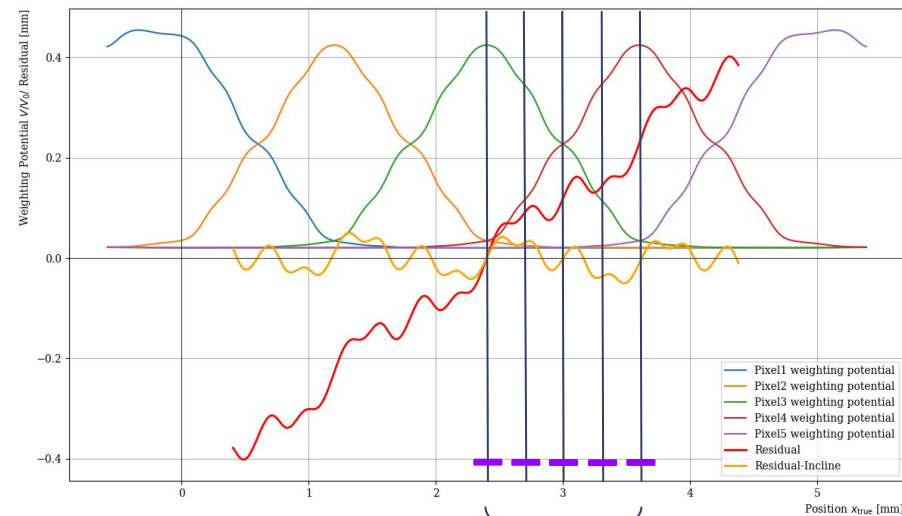
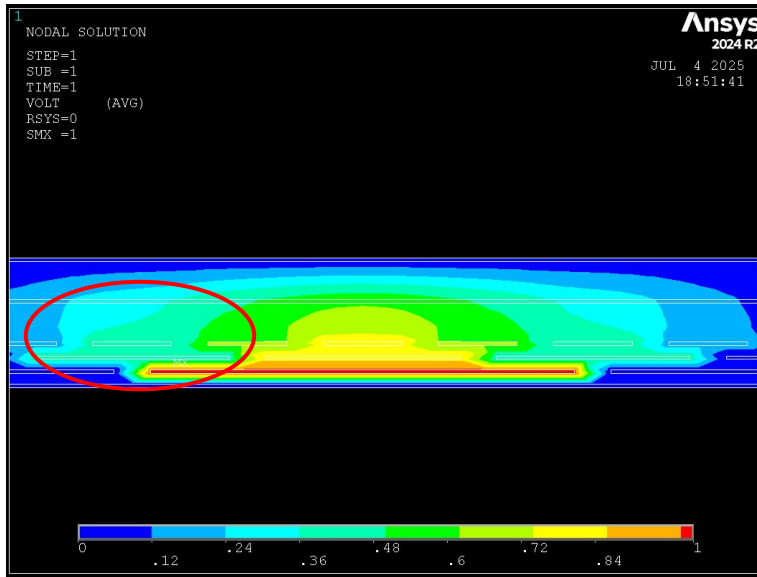
- weighting field $\mathbf{E}(\mathbf{x})$ (electric field) forces floating pixels to carry a constant potential
- expands $\mathbf{E}(\mathbf{x})$ but also propagates upwards (plateaus)



periodicity of the readout
pixels or 4 smallest pixels

Oscillations of the Residual

- weighting field $\mathbf{E}(\mathbf{x})$ (electric field) forces floating pixels to carry a constant potential
- expands $\mathbf{E}(\mathbf{x})$ but also propagates upwards (plateaus)
- more prominent plateaus if pixel layers are aligned (substructure)
- substructure can be reduced by smaller pixel gap (notes Djunes)

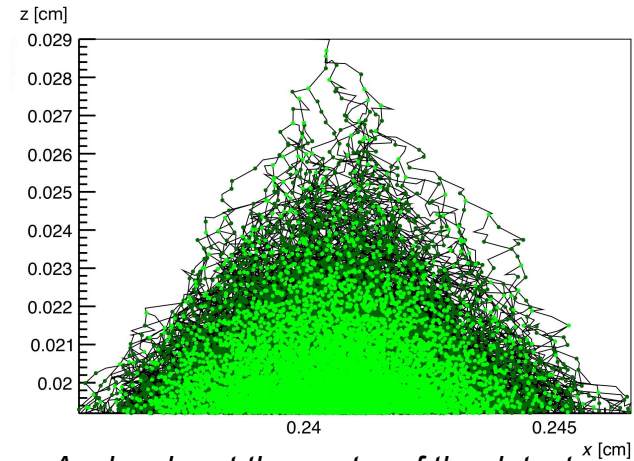
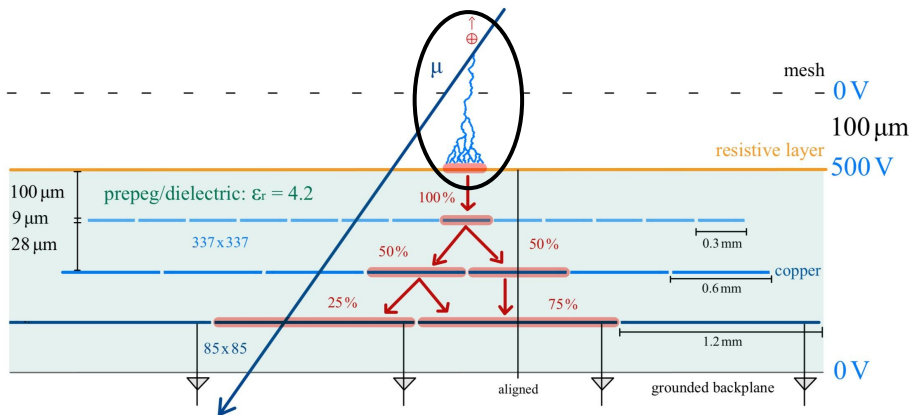


Microscopic Simulation - Garfield++

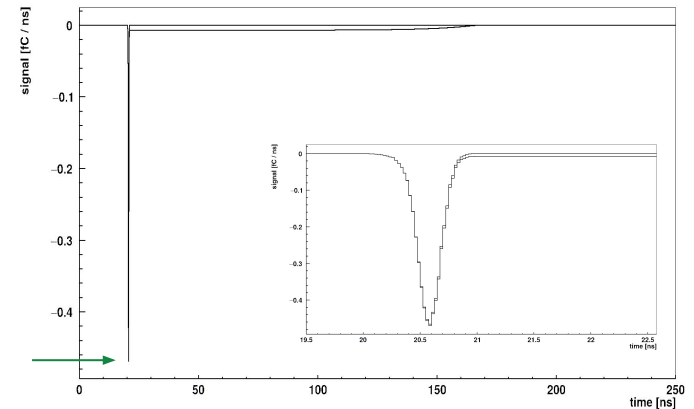
- Simulate detailed electron avalanche $\mathbf{v}(t)$
- Import weighting field $\mathbf{E}(\mathbf{x}(t))$ from Ansys

Garfield can compute the current $i_j(t)$ over time using the Ramo-Shockley Theorem

$$i_j(t) = -q\mathbf{v}(t) \cdot \mathbf{E}(\mathbf{x}(t)) w_{j,j}$$



Avalanche at the center of the detector



Current from e-avalanche. Intense and short electron pulse with long ion tail

Microscopic Simulation - Garfield++

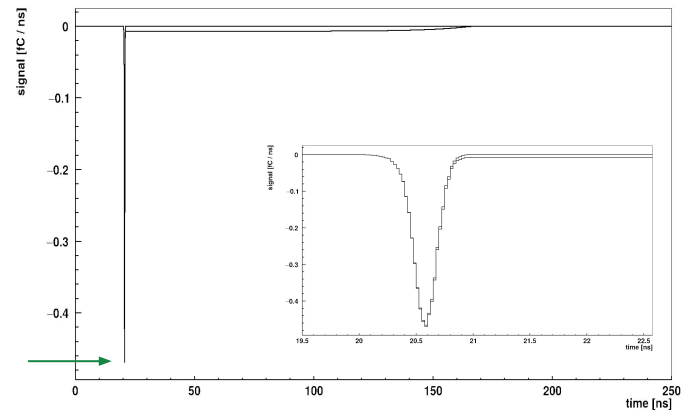
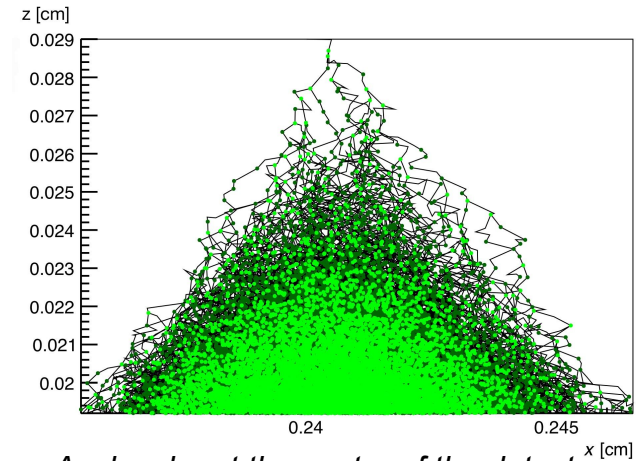
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Maximum current $i_j(t)$ is used as weighting w_i

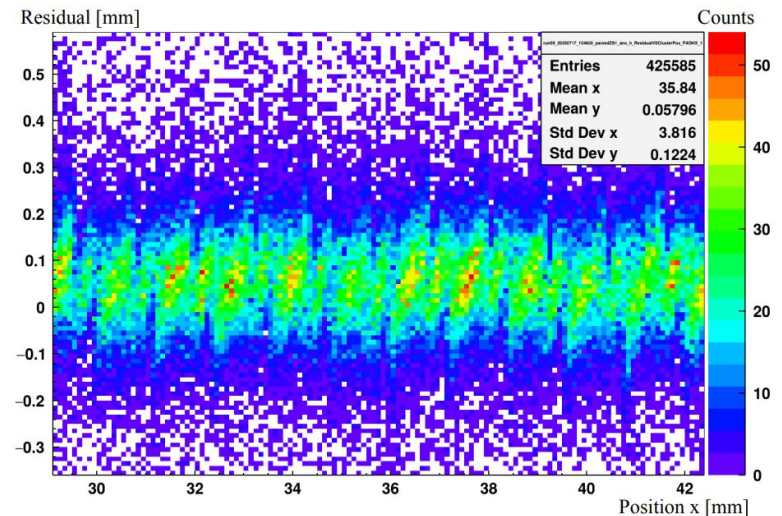
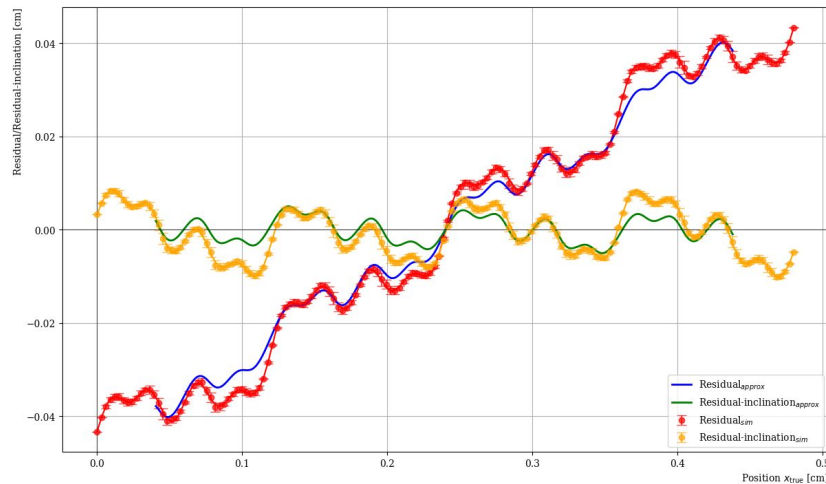
$$x_{rec} = \frac{\sum_{i=1}^n w_i x_i}{\sum_{i=1}^n w_i}$$



Comparison and Measurement

Path integral and avalanche simulation exhibit the same behaviour as expected

Measurements H4 beamtime (CERN SPS 2025) show the same oscillations with substructure

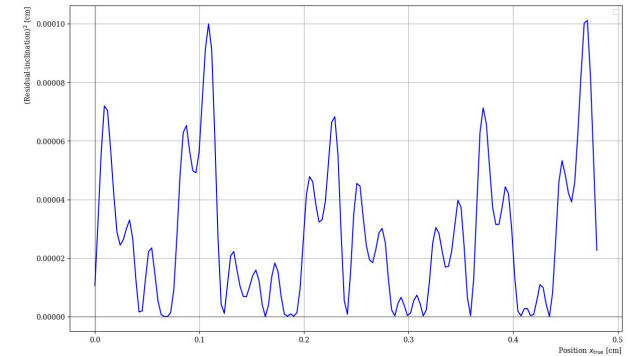


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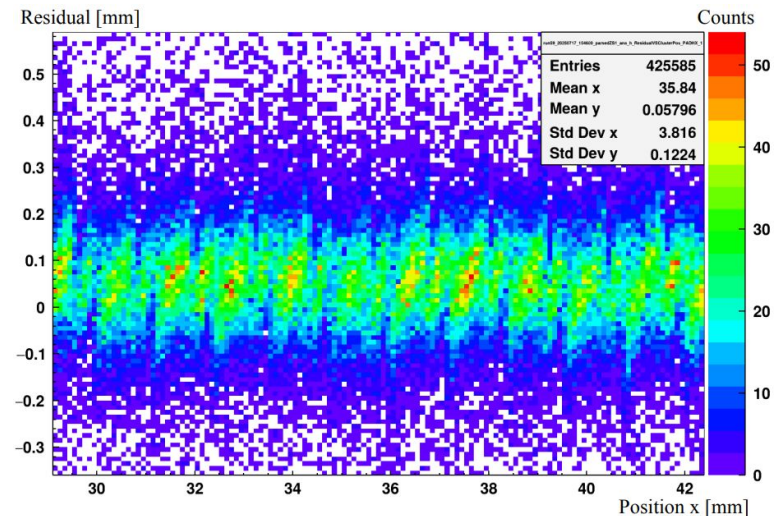
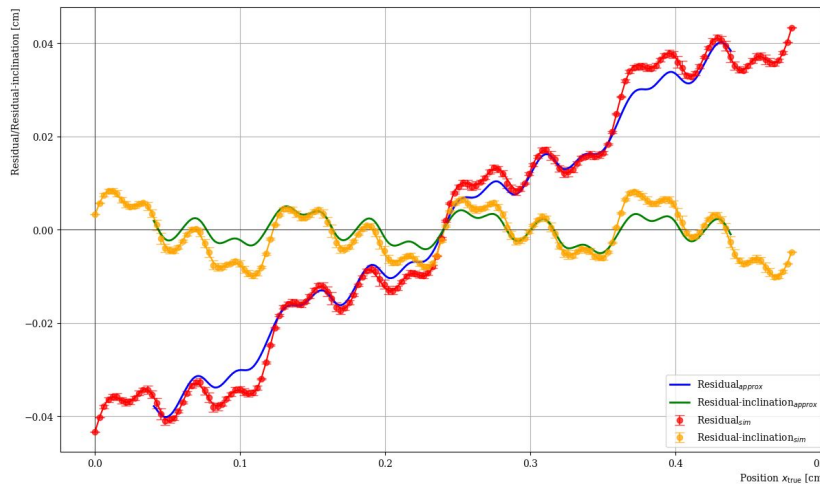
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Measurements H4 beamtime (CERN SPS 2025) show the same oscillations with substructure

The resolution is comparable to a single readout of the smallest pixels

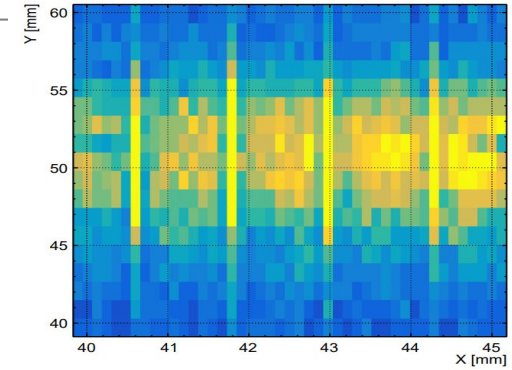
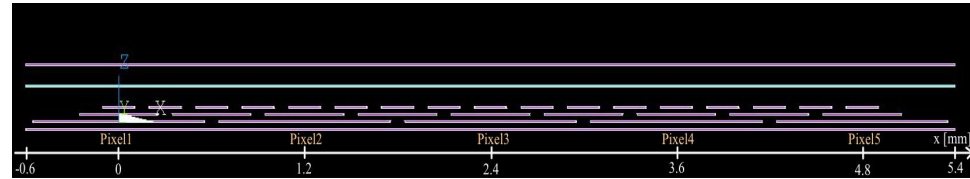


Estimated resolution using the Garfield++ simulation $\sim 55\mu\text{m}$

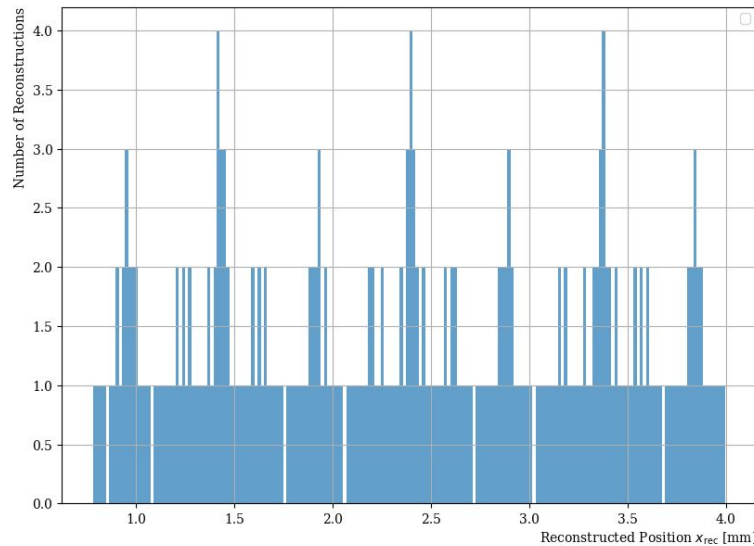


Reconstruction

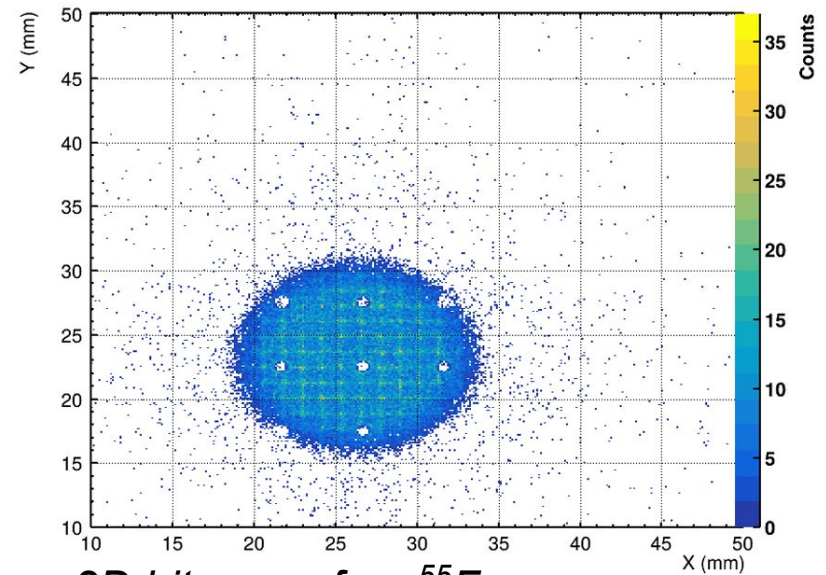
- Histogram of reconstructions and hit map show maxima in the center of the pixels
- Derivative of the residual also peaks there
- Simulation shows a slight deviation from the 1.2mm pitch (presumably limited model size)



Zoomed 1D hit map beam time



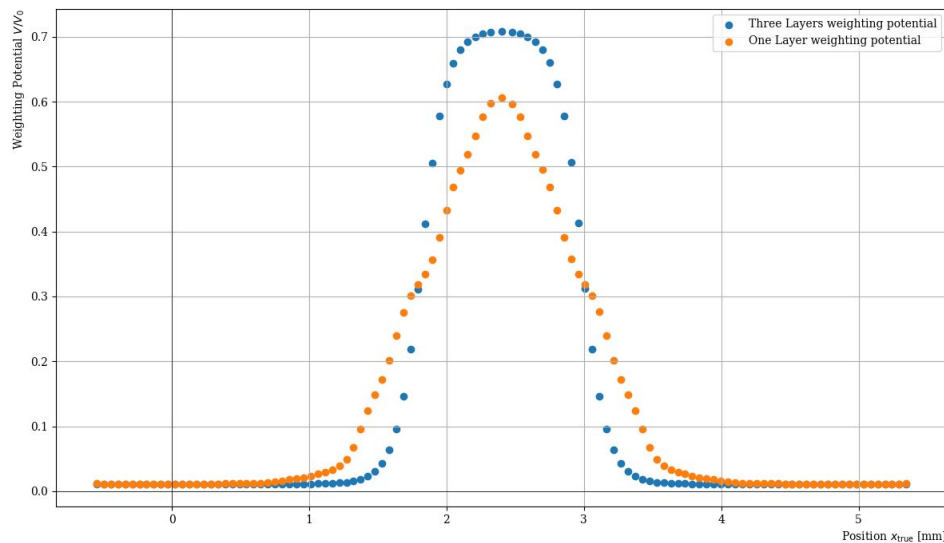
Histogram of reconstructions from simulation



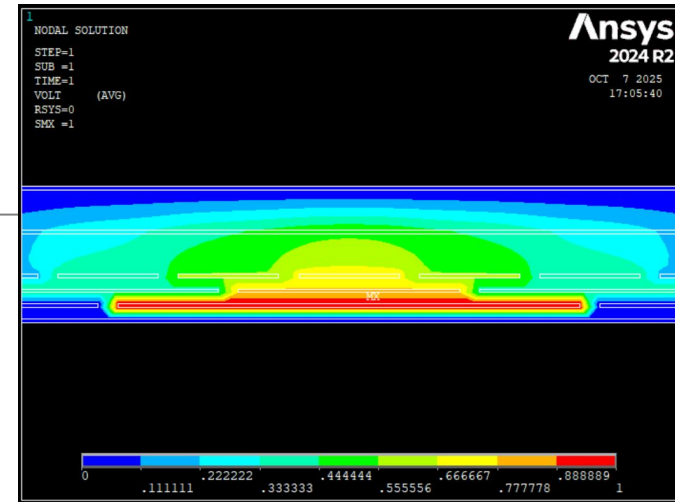
2D hit map of an ^{55}Fe source

Loss of Signal Intensity

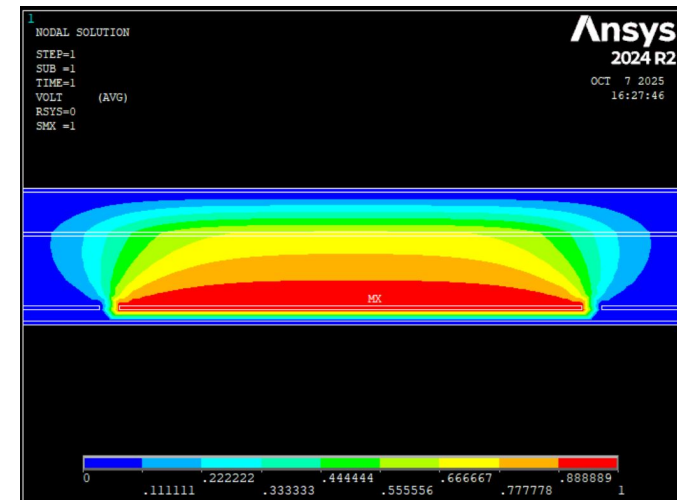
Pixel layers stretch and linearise the potential so we can use the weighted mean for reconstruction. Each layer stretches it further but also damps the signal more. Small plateaus and loss in intensity are the prize.



Projection of weighting field at the dlc



Weighting field with three pixel layers



weighting field without capacitive-sharing

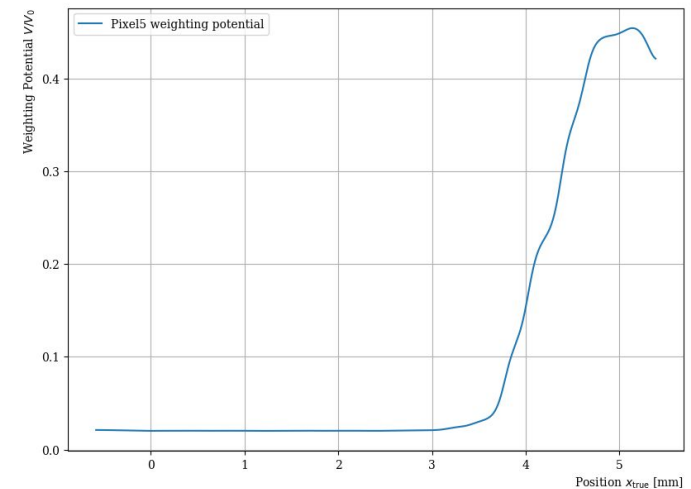
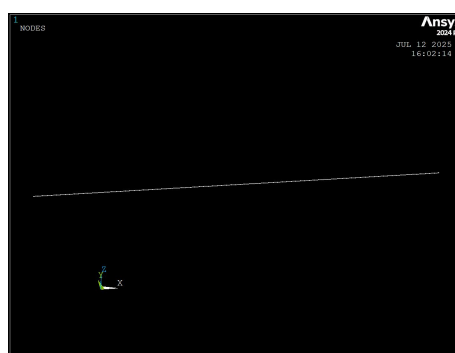
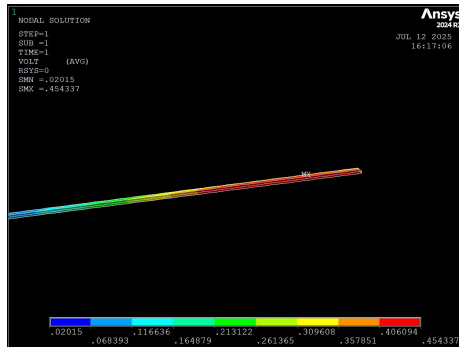
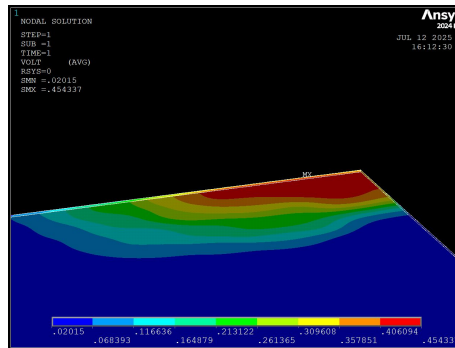
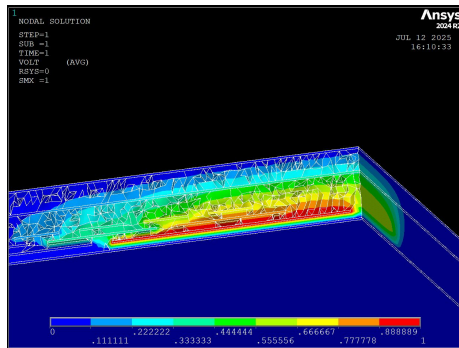
Backup

References for Capacitive Sharing

- [1] Unpublished notes and supporting ideas from Djunes Janssens (Ramo-Shockley Theorem)
- Original idea [Performance of a resistive micro-well detector with capacitive-sharing strip anode readout - ScienceDirect](#)
- [Studies on capacitive sharing resistive Micromegas for Muon System at FCC-ee.pdf](#)
- Bachelor Thesis Max Menzer 2025, supervised by Eshita Kumar [bac25_mmenzer.pdf](#), [Bachelor Theses - Elementary Particle Physics - LMU Munich](#)

Path Integral Projection e.g. Pixel5

Weighting field in one dimension (x-axis) of pixel5 from Ansys

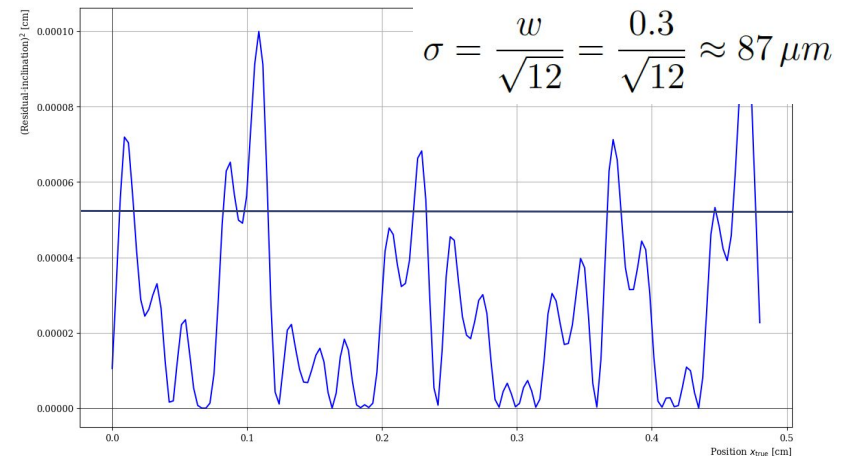
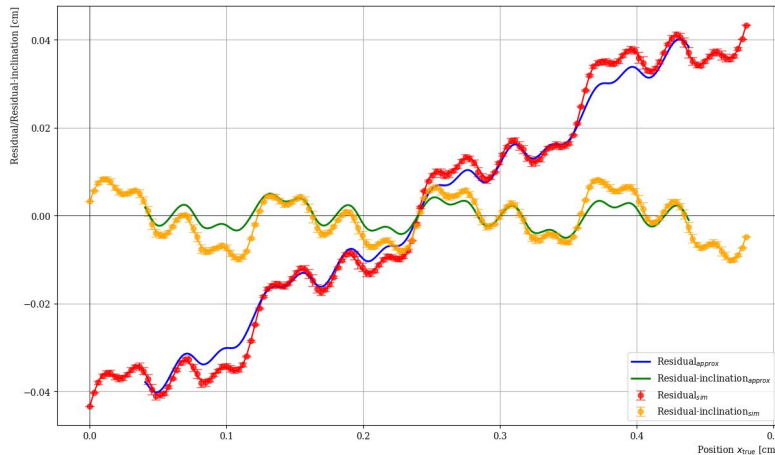
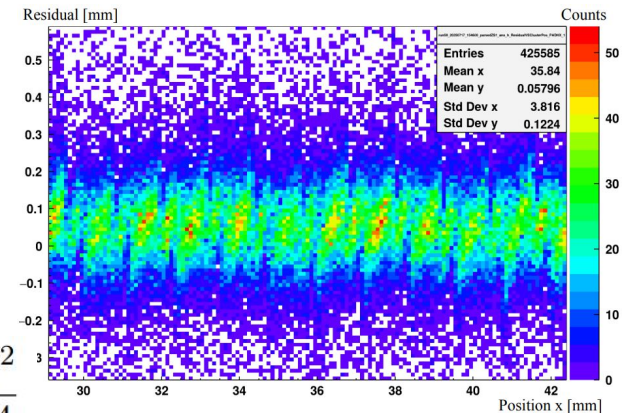


Comparison Residual

Using the residual (orange) to determine the resolution of the detector gives a limit of $\sim 55\mu\text{m}$

Shows that the resolution is even better than the classical readout without weighted mean

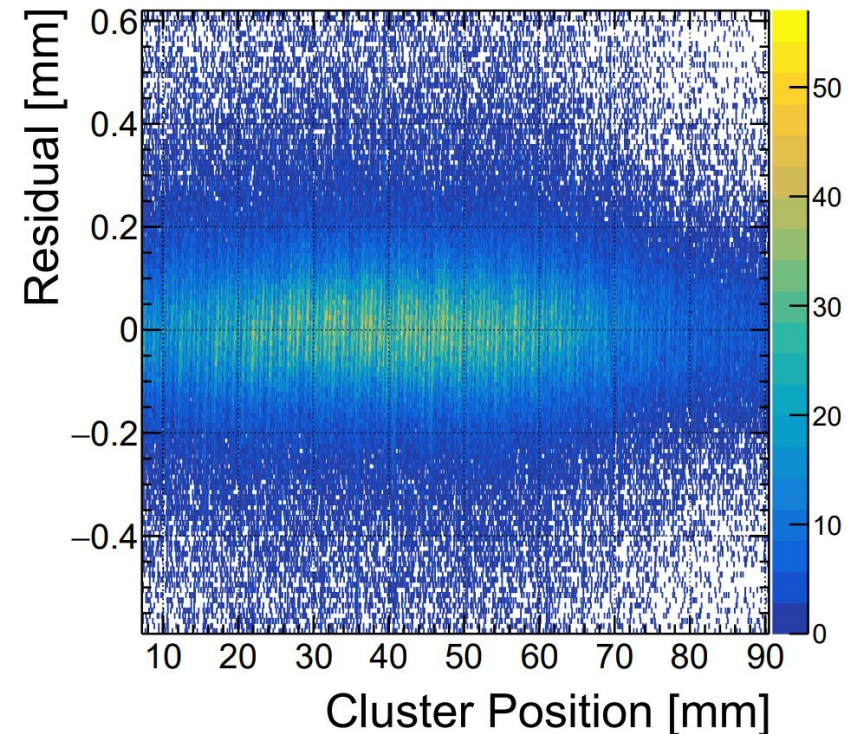
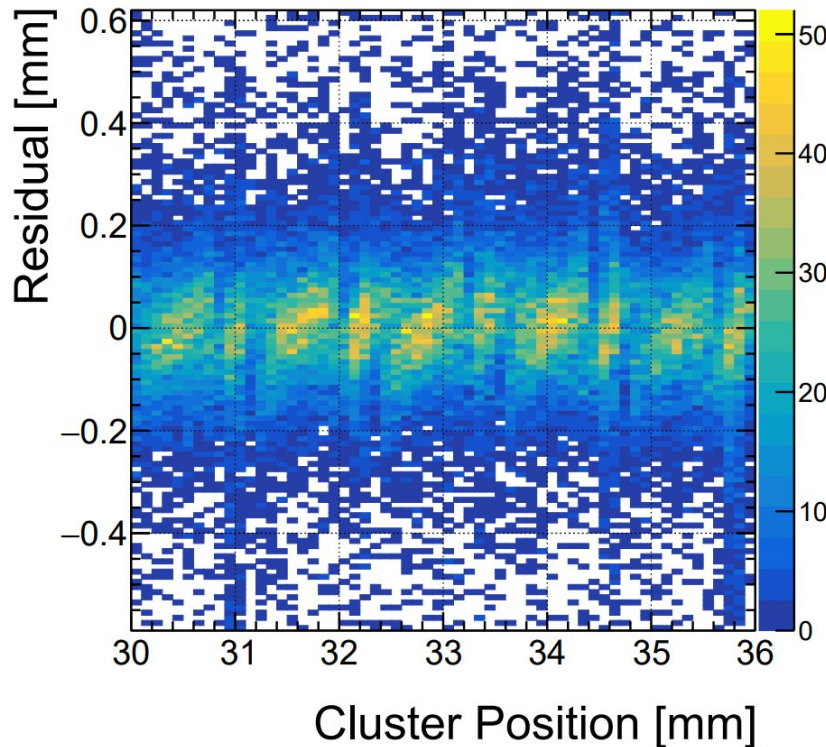
$$\sigma^2 = \frac{1}{w} \int_{-\frac{w}{2}}^{\frac{w}{2}} (x)^2 dx = \frac{1}{w} \left[\frac{x^3}{3} \right]_{-\frac{w}{2}}^{\frac{w}{2}} = \frac{1}{w} \frac{(w/2)^3}{3} - \frac{(-w/2)^3}{3} = \frac{w^2}{24}$$



Squared residual (orange) for resolution

Additional Measurements H4 beamtime (CERN SPS25)

Measurements were carried out by Eshita Kumar and will be explained further tomorrow, Thu 09/10/25 11:45, DRD1



CLASSE		7		Ep. TOTALE		2,2	
EMPILAGE							
Nom							
cov2	Coverlay	Coverlay 128μ + Mesh + 64μ	env 0.2				
cov1	Finition	Passivation					
DLC	DLC	0,1					
	Matière	APICAL + DLC	Epaisseur 0,05				
	Type de colle	prepreg no flow 1x50	Ep. 0,05				
	Finition	Passivation					
PAD0	Feuillard Cu	9					
	Surface cu :	5,41 dm					
	Type de colle	prepreg 1x28	Ep. 0,028				
PAD1	Feuillard Cu	9					
	Surface cu :	4,75 dm					
	Type de colle	prepreg 1x28	Ep. 0,028				
PAD2	Feuillard Cu	9					
	Surface cu :	4,87 dm					
	Type de colle	prepreg 1x28	Ep. 0,028				
TOP	Feuillard Cu	17 35					
	Surface cu :	5,72 dm					
	Type de colle	PREPREG 2x125	Ep. 0,25				
I2	Cuivre de base	17					
	Surface cu :	4,42 dm					
	Matière	EPOXY	Ep. 0,5				
I3	Cuivre de base	17					
	Surface cu :	4,44 dm					
	Type de colle	PREPREG 2x125	Ep. 0,25				
	Matière	EPOXY	Ep. 1				
	Surface cu :	9,97 dm					
BOT	Cuivre de base	17 35					
	Finition	Passivation					

Stackup Three
Layer Detector
PADH used for
measurements

MicroMegas (Micro-Mesh Gaseous Detector)

Goal: Position and Timing of particle passing through (e.g. μ)

1. Ionization and Drift region

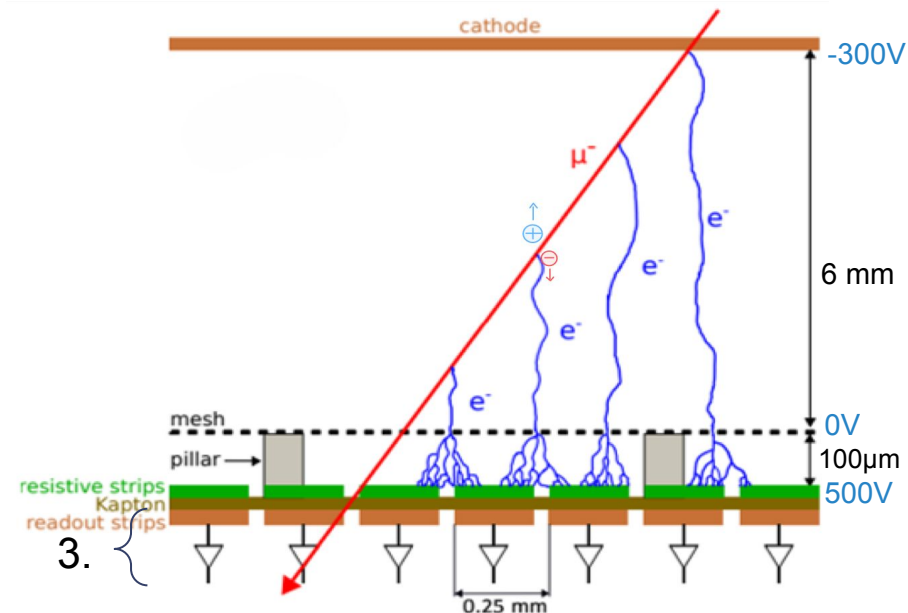
- Charged particle ionizes gas
- E-field prevents recombination of e^- and ions
→ e^- drift towards mesh

1. Amplification

- Strong E-field between mesh and readout
- e^- avalanche
→ enough charge to detect

1. Readout

- Transform “charge cloud” into signal
- Easiest: direct readout



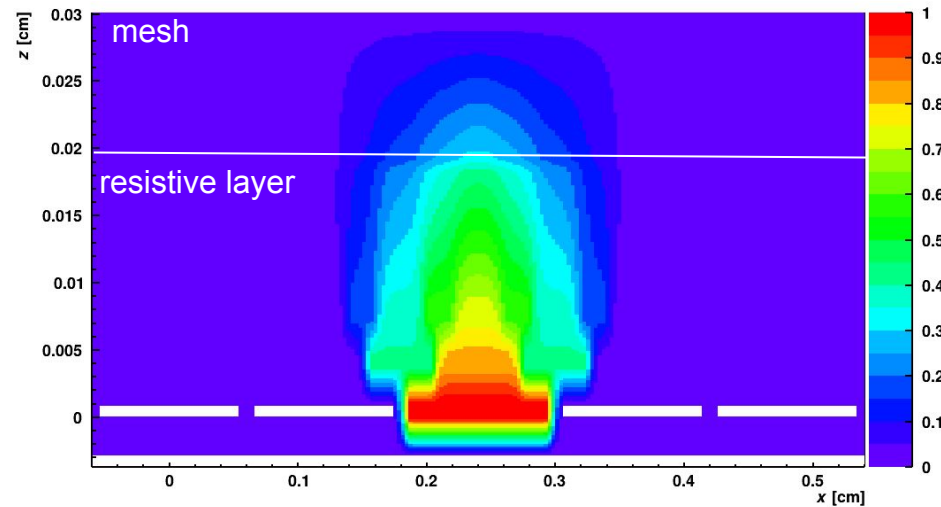
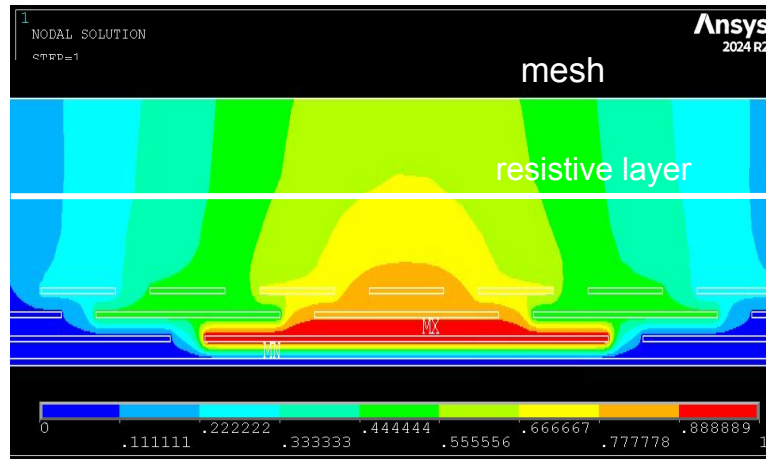
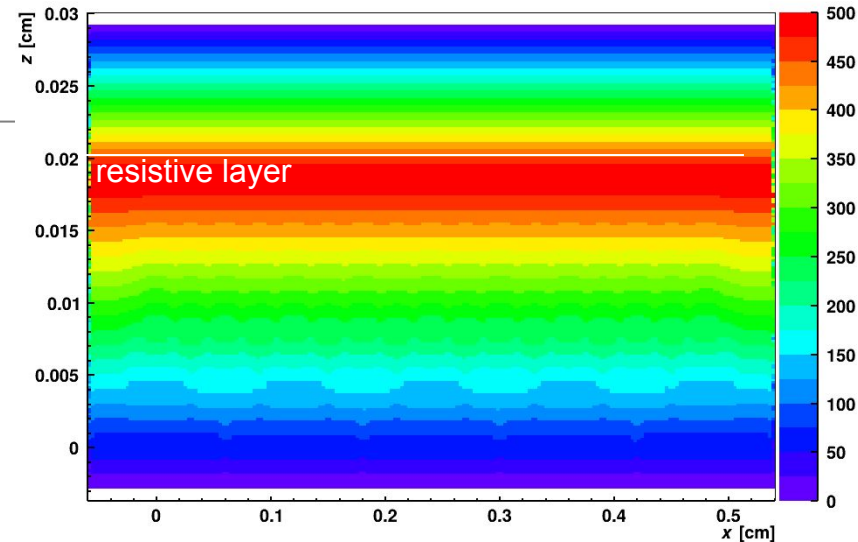
Problem:

- many readout channels (electronics)
- $10 \times 10 \text{ cm} \rightarrow \sim 150\,000$

Import fields to Garfield++

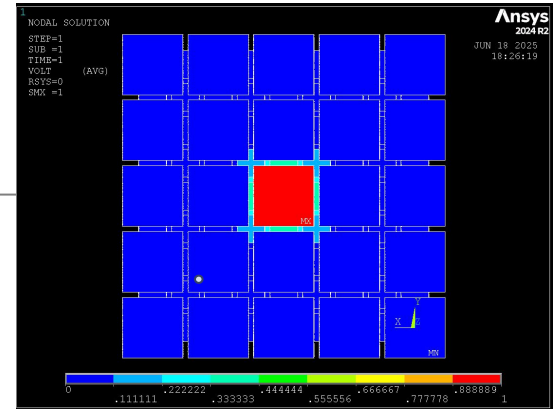
Garfield - electric field
(amplification)

weighting field
(mathematical concept)



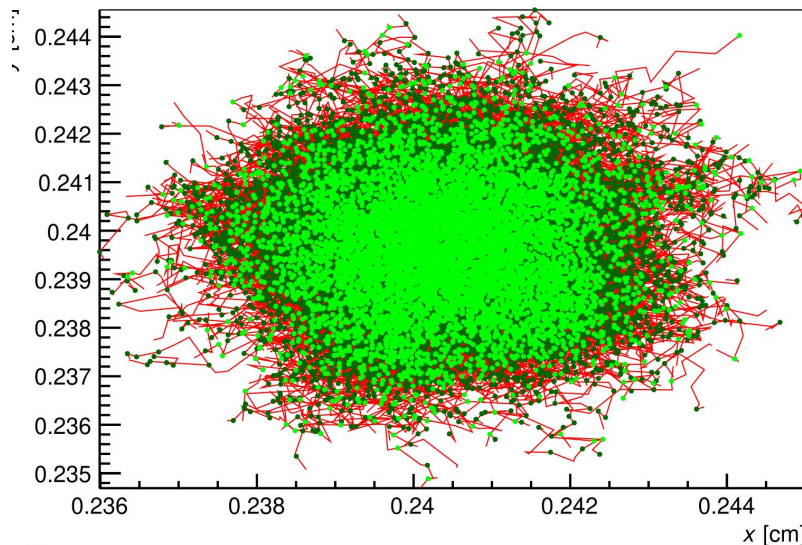
Electron avalanche

Centered above the center readout pixels

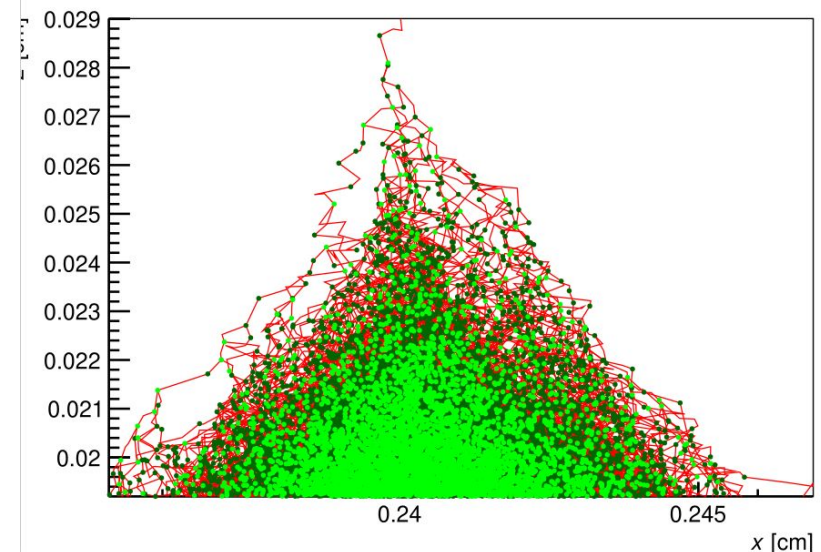


pixel size 1.2mm
avalanche spread 0.1mm

top view (xy-plane)



side view (xz-plane)
cross section



Capacitive-Sharing Pixel Micromegas

Overview

- Micromegas Readout
- Capacitive-Sharing
- Explanation using the Ramo-Shockley Theorem
- Simulation using ANSYS
 - Path Integral
 - Microscopic Simulation (Garfield++)
- Comparison to Measurements

